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PATENT APPLICATION  
Docket No: 11675.114

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of )  
 )  
 Kei-Yu Ko )  
 )  
 Serial No.: 08/846,671 )  
 )  
 Filed: April 30, 1997 )  
 )  
 For: UNDOPED SILICON DIOXIDE AS AN ETCH )  
 STOP FOR SELECTIVE ETCH OF DOPED )  
 SILICON DIOXIDE )

CERTIFICATE OF DEPOSIT UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail, postage prepaid, in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231, on July 12, 1997.

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Registration No. 34,521

Transmitted: Information Disclosure Statement  
Form PTO-1449 Listing of All References  
Legible Copies of All Listed References  
Postcard

BKD:dff  
Enclosures  
Docket: 11675.114  
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Rev. 9/95



entirety) of which the undersigned is presently aware, and no art which is closer to the claimed invention (taken in its entirety) has been knowingly withheld.

In accordance with 37 C.F.R. §§ 1.97 and 1.98, a copy of each of the listed references or relevant portion thereof is also enclosed.

Since all listed references are either in the English language or are accompanied by a translation into English, no concise explanation of relevance is required under 37 C.F.R. § 1.98(a)(3).

Dated this 12 day of July, 1997.

Respectfully submitted,



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